Docket No.: INF-P08224 US

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Ву:

Date: November 25, 2002

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant

Gerhard Beitel et al.

Applic. No.

09/734,467

Filed

December 11, 2000

Title

Methods for Producing a Structured Metal Layer

Examiner

Ida M. Soward

Art Unit: 2822

UNDER 37 C.F.R. 1.97(C)(1)

Hon. Commissioner of Patents and Trademarks, Washington, D.C. 20231

Sir:

In accordance with 37 C.F.R. 1.98 copies of the following patents and/or publications are submitted herewith:

United States Patent No. 5,714,402 (Choi), dated February 3, 1998;

United States Patent No. 5,789,268 (Chivukula et al.), dated August 4, 1998;

Japanese Patent Abstract JP 11 121 411 (Kawaguchi), dated April 30, 1999.

In accordance with 37 C.F.R. 1.97(e) the undersigned herewith states that each item of information contained in the information disclosure statement was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of the information disclosure statement.

DEC-2 2001

If no translation of pertinent portions of any foreign language patents or publications mentioned above is included with the aforementioned copies of those applications, patents and/or publications, it is because no existing translation is readily available to the applicant.

In accordance with 37 C.F.R. 1.97 (c) (1), consideration of this Information Disclosure Statement is requested.

Respectfully submitted,

For Applicants

Mark P. Weichselbaum Reg. No. 43,248

Date: November 25, 2002

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